Docket No.:

EHF 2001,0167 F

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**Applicant** 

Norbert Benesch et al.

Appl. No.

09/873,230

Filed

June 4, 2001

Title

Method and Device for Optically Monitoring Fabrication

Processes of Finely Structured Surfaces in a Semiconductor

Production

Art Unit

## ASSOCIATE POWER OF ATTORNEY

Hon. Commissioner of Patents and Trademarks, Washington, D.C. 20231

Sir:

Please recognize GREGORY L. MAYBACK (Reg. No. 40,719) as my associate in the matter in the above-identified application, with full powers. Please continue addressing all communications to the following address:

Lerner and Greenberg, P.A. P.O. Box 2480 Hollywood, Florida 33022-2480

Respectfully submitted,

For Applicant(s)

WERNER H. STEMER

RL

**.** 34,956

Date: August 8, 2001

Lerner and Greenberg, P.A.

Post Office Box 2480

Hollywood, FL 33022-2480

Tel:

(954) 925-1100

Fax:

(954) 925-1101

/mjb